

Compact Micro-Flow air leak test instrument: testing in pressure and vacuum conditions





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The E-PDQ is designed for the quick production leak testing of small components and ensures that products meet their leak tightness requirements. Its compact design makes the E-PDQ perfectly suitable for system integration.

It is available as EQ version for pressure applications and as MQ version for vacuum applications.

Customer benefits

- Compact design easy integration
- Integrated pressure (respectively vacuum) reservoir simple test setup
- Cost-efficient fast return on investment

Solution example



Multi-stations leak and flow test system for the life science industry



Medical devices



Electronics



Valves

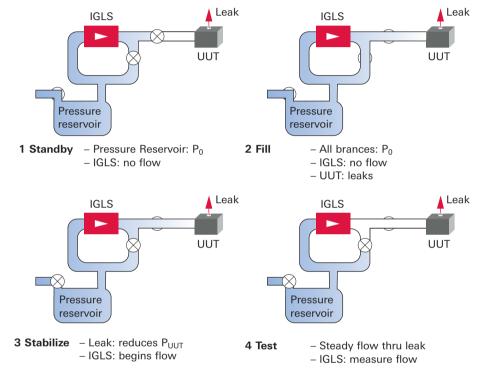


Customer benefits

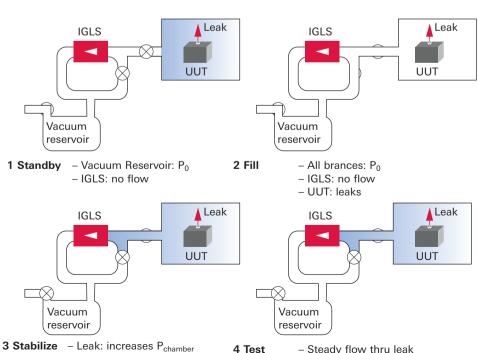
- Compact design for small footprint
- Rack-mounted design for testing multiple cavities simultaneously with the same machine
- Version EQ for Micro-Flow pressure testing
- Version MQ for Micro-Flow testing under vacuum
- Automated test circuit with valves and sequence controller
- Digital and analog I/O interface via Ethernet or serial port
- Easy-to-read LED that indicates test status: test, pass or fail

Leak detection methods

Air leak testing with Micro-Flow sensor at pressure conditions



Air leak testing with Micro-Flow sensor at vacuum conditions



IGLS = Intelligent Gas Leak Sensor

- IGLS: begins flow

4 Test - Steady flow thru leak

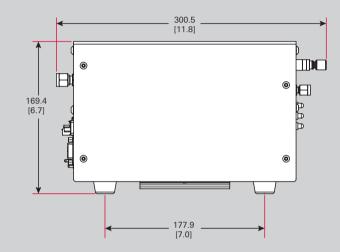
- IGLS: measure flow thru leak

Dimensions

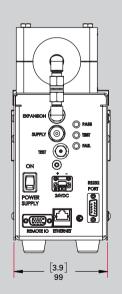
Dimensions

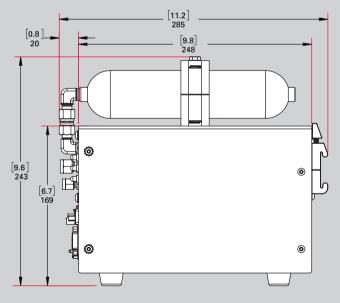
E-PDQ Standard





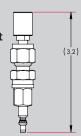
E-PDQ DIN Rail back mount with 300 ccm additional tank





E-PDQ Verification Quick Disconnect

Verification Quick Body type: BP



Dimensions in mm
[XX] Dimensions in inch

Technical data, accessories and order number matrix

Technical data¹⁾

	E-PDQ	
	EQ	MQ
Applicable Micro-Flow sensors	IL2-M, IL2-KM	
Leak rates / sensitivity	0.03 cc/min and higher	
Pressure ranges	> 14.5 psia / 1 bar abs. to 65 psia / \approx 4.5 bar abs.	2 psia / 0.138 bar abs. to 14.5 psia / 1 bar abs.
Dimensions	4" W x $6.25"$ H x $10"$ D / 102 x 159 x 254 mm (does not include connections and fittings)	
Gases	Dry, clean gases: air, nitrogen (further gases detectable)	
Pneumatic connections	Test port 1/8 inch Swagelok®, air/vacuum supply 1/4 inch Swagelok®	
Digital inputs	5-30 VDC, Opto-Isolated for start, stop, test type, remote pressure switch	
Digital outputs	5-30 VDC, Opto-isolated for pass, fail, test type, test on, clamp, custom output	
Analog outputs	Single channel, 0-5 VDC pressure control	
Power supply	24 VDC (maximum current is 2 amp)	
Interfaces	RJ-45 Ethernet, or RS-232 Serial Interface	

¹⁾ Specific technical specification depends on the sensor used. We are happy to support you in selecting the perfect configuration for your application.

Accessories

	E-PDQ
LeakTek™	
Adaptive Test™ utility tools	
Leak Rx™	
Expansion tank: small/medium	
Expansion tank: large	
Precision pressure regulator: small/medium volume	
Verification orifice: ECD or SE (ECD-X-PSE-X-P)	
Verification orifice: ECS air calibration	
Glass orifice: calibrated at barometric inlet, vacuum outlet on primary std.	
Remote exhaust valve with filter	
Oil-free vacuum generation and control package (ca. 0.3-0.8 bar abs.)	
Oil-free vacuum generation and control package (ca. 0.07-0.15 bar abs.)	•
Shallow vacuum generation and control package	•
Remote pendant with Start/Stop button	•
Mass Extraction UUT filter	
Quick connector with plug	

Order number matrix Order number E-PDQ abcdefghijk Version ab EQ – pressure applications EQ MQ - vacuum applications MQ Full scale flow (cc/min) cdefg 0500M 0.5 cc/min 1000M 1 cc/min 3 cc/min 3000M 5 cc/min 5000M 10 cc/min 010KM 25 cc/min 025KM 50 cc/min 050KM 100 cc/min 100KM 250KM 250 cc/min Operating pressure (Psia / bar) hi 15 Psia / ≈ 1 bar abs. (MQ – vacuum applications) 15 30 Psia / ≈ 2 bar abs. (EQ – pressure applications) 30 65 Psia / \approx 4.5 bar abs. (EQ – pressure applications) 65 Mounting configuration (both options include rubber bumper feet) Bottom mount DIN rail В Back mount DIN rail D Additional 300 ccm expansion tank 300 ccm tank mounted to top cover Т No additional tank (standard configuration) (Blank)

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All data subject to change without prior notice. PL 0021 PEN (October 2019/PoD)

